

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hajime KANAZAWA, et al.
Serial No.: 10/808,657
Filed: March 25, 2004
For: APPARATUS AND METHOD FOR MEASURING EUV LIGHT INTENSITY DISTRIBUTION

Group Art Unit: 2884
Examiner: Shun K. Lee

AMENDMENT

Mail Stop - **RCE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please enter this Amendment in the above-identified application before continued examination on the merits. A Request for Continued Examination (RCE) is being filed concurrently herewith. This Amendment and accompanied RCE have been filed in response to the final Office Action mailed September 8, 2006. Entry and reconsideration are respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.